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I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING TRANSMITTED BY FACSIMILE TO THE U.S. PATENT AND TRADEMARK OFFICE AT FAX NUMBER 571-273-8300 ON THE DATE INDICATED BELOW.

By (Printed name): Amy Barger Date: May 26, 2006

Signature: Amy Barger Mail Stop RCE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of:
Ravikumar Ramachandran et al. :
Conf. No.: 4256 : Group Art Unit: 2822
Appln. No.: 10/710,257 : Examiner: Khanh B. Duong
Filing Date: June 29, 2004 : Attorney Docket No.: FIS920040102US1
Title: **METHOD OF FORMING SIDEWELL SPACER USING PLASMA ENHANCED CVD**

AMENDMENT TO ACCOMPANY REQUEST FOR CONTINUED EXAMINATION
UNDER C.F.R. 1.114

The following Amendment is submitted with an accompanying Request for Continued Examination in response to the final Office Action dated March 29, 2006 in the above-identified patent application. This amendment is being filed within the three-month statutory period set for a response. Please amend the above-identified U.S. patent application, without prejudice, as follows.

Amendments to and Listing of the Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.